

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Eiichi SHIMIZU et al.

Application No.: 10/589,348

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Art Unit: 1792

For: VAPOR PHASE GROWTH APPARATUS

Examiner: R. N. Kackar

AMENDMENT UNDER 37 CFR 1.114

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Madam:

INTRODUCTORY COMMENTS

The following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.